

Search Notes

Application No.

10/694,083

Examiner

D. Rutledge

Applicant(s)

TAKASHIMA, TSUNEO

Art Unit

2851

SEARCHED

Class	Subclass	Date	Examiner
355	53, 72,76	11/26/2004	DR
310	10, 12	11/26/2004	DR
318	649	11/26/2004	

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
355	52,72,76	11/27/2004	DR
310	10, 12	11/26/2004	DR
318	649	11/27/2004	DR

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
positioning; stage or table; reference adj plane; reaction near3 force; motor; distance; equal; first; second; third; fourth	11/26/2004	DR
absorb\$3; line near2 action near2 force; stator; motor; gravity near2 center; position or location; projection; exposure;	11/26/2004	DR
lithography or microlithography or photolithography; fine adj motion or movement; guid\$3	11/26/2004	DR